

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2814
 Serial No. : 09/362,808 Examiner : Shrinivas H. Rao
 Filed : July 28, 1999 Conf. No. : 7320
 Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP RCE

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Please consider the references listed on the enclosed PTO-1449 form. Foreign patent documents and non-patent literature are enclosed; cited U.S. patents and patent application publications will be provided on request.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
AL	JAPAN 02-025024 – Full translation
AM	JAPAN 02-278749 – Full translation
AN	JAPAN 05-275373 – Full translation
AO	JAPAN 06-175156 – Full translation
AP	JAPAN 07-058107 – Full translation

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Roberto J. Devoto
 Reg. No. 55,108

Date: 6/17/06
 Customer No. 26171
 Fish & Richardson P.C.
 1425 K Street, N.W.
 11th Floor
 Washington, DC 20005-3500
 Telephone: (202) 783-5070
 Facsimile: (877) 769-7945